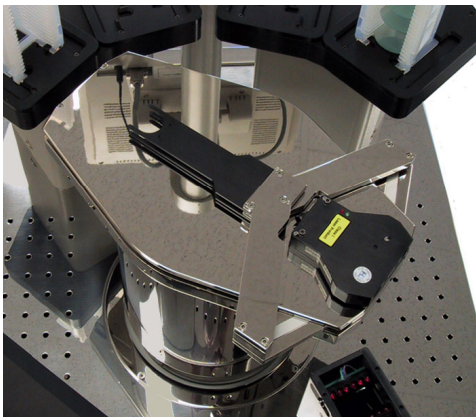


- High speed dual arm robot
- Non-contact wafer center and flat/notch find
- Multiple wafer size recognition from 2” to 300mm
- Up to 4 cassette platforms
- SECS II/GEM/HSMS
- User customizable screens
- Multi-level password protection
- Recipes created on or offline
- Smallest Footprint - 24” x 40”



*“Essential Sorting and Wafer Tracking System”*



- Virtual Tweezer mode allows operator to easily move wafers between cassettes or slots
- MicroSORT scripting with unlimited recipe capability.